03500.015 19 JAN 0 7 7002 W

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#6 /IDS 8/6/02 18

In re Application of:)
	: Examiner: Unassigned
Tohru DEN)
	: Group Art Unit: 1773
Application No.: 09/940,575)
	:
Filed: August 29, 2001)
	:

The Commissioner for Patents Washington, D.C. 20231

For: MAGNETIC DEVICE

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INFORMATION DISCLOSURE STATEMENT

)

January 7, 2002

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The Examiner's attention is also directed to the following U.S. Application:

In accordance with 37 CFR 1.98(a)(2)(iii), a copy of the cited U.S. application is enclosed.

*: considered by 5. Hu on 3-18-03.

Japanese Patent Laid Open Nos. 10-190090, 11-224422 and 10-283618, cited in the enclosed Form PTO-1449, are cited in the specification and are relevant for the reasons noted therein. The documents are discussed in the specification as follows:

Document	<u>Page</u>
JP 10-190090	4
JP 10-283618	8
JP 11-224422	. 8

The <u>Furneaux</u>, et al. reference entitled "The Formation of Controlled-Porosity Membranes From Anodically Oxidized Aluminium" is discussed at page 6 of the specification and is relevant for the reasons discussed therein.

The Masuda, et al. reference entitled "Fabrication of Gold Nanodot Array Using Anodic Porous Alumina as an Evaporation Mask" is discussed at page 7 of the specification and is relevant for the reasons discussed therein.

The <u>Masuda</u> reference is discussed at page 8 of the specification and may be relevant for the reasons discussed therein. At present, an English language translation of the <u>Masada</u> reference is not available to Applicant. However, Applicant will obtain a translation if requested by the Examiner.

U.S. Patent No. 6,139,713 is discussed at page 8 of the specification.

U.S. Patent No. 5,764,567 is the English counterpart to JP 10-190090. In addition, Applicants have obtained, from a commercial database, English language abstracts for JP 10-190090, JP 10-283618, and JP 11-224422. Copies of these abstracts are enclosed for the Examiner's convenience and listed on the Form PTO-1449.

FORMAL MATTERS

In accordance with 37 C.F.R. § 1.97(b), since a first Official Action on the

merits of the subject application has not yet been issued, neither a certificate, petition nor

payment of a fee is believed to be required for this Information Disclosure Statement.

However, the Commissioner is hereby authorized to charge any fee which may be required in

connection with this paper to Deposit Account No. 06-1205. A duplicate of this paper is

enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the

Examiner and that the enclosed Form PTO-1449 be returned indicating that such information

has been considered.

Applicant's undersigned attorney may be reached in our Washington, D.C.

office by telephone at (202) 530-1010. All correspondence should continue to be directed to

our below-listed address.

Respectfully submitted,

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